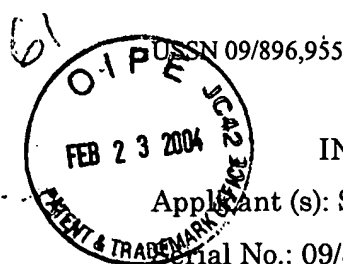


AF  
1762



USPN 09/896,955

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED

Applicant (s): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

FEB 25 2004

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO<sub>2</sub> BY CHEMICAL VAPOR DEPOSITION AT ROOM TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT BY FIRST CLASS MAIL ON February 18, 2004 DATE OF DEPOSIT Gary C. Cohn PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE _____ SIGNATURE OF PERSON SIGNING CERTIFICATE
--

Hon. Commissioner of Patents & Trademarks  
Washington, D.C. 20231

Sir:

RESUBMISSION OF RESPONSE

On January 6, 2004, the undersigned submitted a response, petition for extension of time, fee sheet and credit card authorization form to the USPTO by facsimile to telephone number 703-872-9306. Our facsimile machine printed a conformation report, indicating that the entire 9 pages of the facsimile were successfully sent to a fax machine that identified itself as "USPTO". However, no facsimile auto-transmission was received from the USPTO in response to the fax.

On February 17, Examiner Meeks of Art Unit 1762 called to inquire whether a response had been filed. Examiner Meeks informed us that the facsimile transmission had not been recorded by the USPTO.

Examiner Meeks suggested that we refile the response of January 6, 2004, without payment of additional fees.

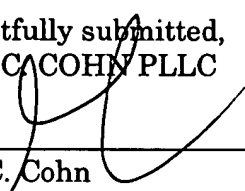
Therefore, this paper is being filed to resubmit the papers that were filed on January 6.

Enclosed with this paper are:

- (1) Copy of the confirmation report generated by our fax machine, verifying that the January 6 fax was sent and received.

(2) Copy of the papers filed January 6, 2004. The copy of the credit card authorization form sent on January 6 has been marked "COPY".

Respectfully submitted,  
GARY C. COHN PLLC



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Gary C. Cohn  
Registration No. 30,456  
Phone: (425) 576-1656  
4010 Lake Washington Blvd. NE  
Suite 105  
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RECEIVED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE FEB 25 2004

Applicant (s): Steven M. George et al.

Serial No.: 09/896,955

Group Art Unit: 1762

Filed: June 29, 2001

Examiner: Meeks

For: METHOD FOR FORMING SiO<sub>2</sub> BY CHEMICAL VAPOR DEPOSITION AT ROOM TEMPERATURE

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING SENT	
BY FACSIMILE ON January 6, 2004	
DATE OF DEPOSIT	
Gary C. Cohn	
PRINT OR TYPE NAME OF PERSON SIGNING CERTIFICATE	
SIGNATURE OF PERSON SIGNING CERTIFICATE	

Hon. Commissioner of Patents & Trademarks  
Washington, D.C. 20231

Sir:

RESPONSE B

This paper is submitted in response to the office action in this case mailed August 6, 2003. A two-month extension of time is hereby requested. The required fee is being submitted with this paper.

The examiner is respectfully requested to enter the following amendments and to reconsider the application in view of the following remarks.

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